

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Zheng, et al.

Serial No.: 09/614.407

Confirmation No.: 1903

Filed:

July 12, 2000

For:

Method of Application of

**Electrical Biasing To** 

**Enhance Metal Deposition** 

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Group Art Unit: 1753

Examiner:

Brian L. Mutschler

MAIL STOP RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

## **CERTIFICATE UNDER 37 CFR 1.10**

I hereby certify that this correspondence and the documents referred to as attached therein are being deposited on March \_\_\_\_\_\_\_\_, 2004 with the United States Postal Service in an envelope as "Express Mail Post Office to Addressee," mailing label No. \_EV335477774US addressed to: Mail Stop RCE, Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

3/8/04

Signature

## REQUEST FOR NON-ENTRY OF AMENDMENT

Applicants respectfully request non-entry of the Response to the October 20, 2003 Final Office Action mailed on December 22, 2003.

Respectfully submitted,

Keith M. Tackett

Registration No. 32,008

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